

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

ATTY. DOCKET NO. 1268-254

U.S. PATENT APPLICATION NO. 10/566,369

APPLICANT

APPLICATION (PTO/SB/O8A)				Oleg NAIGERTSIK et al.			
				FILING DATE January 30, 2006		GROUP	
		U.S. P.A	TENT D	OCUMENTS			
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME		CLASS	SUBCLASS	FILING DATE
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EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY		Abstract	Translation	Equivalent
/T.T./	0281034	9/1988	EP				
/T.T./	0581651	2/1994	EP				
/T.T./	0934773	8/1999	EP				
/T.T./	2703927	10/1994	FR				
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/T.T./	2780901	1/2000	FR				
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/T.T./	Aizawa et al., "Preparation of Spherical Hydrous Silica Oxide Particles under Acidic Condition via Sol-Gel Processing," JOURNAL OF SOL-GEL SCIENCE AND TECHNOLOGY 19, 329-332, 2000						
/T.T./	Avnir et al., "Organic Fluorescent Dyes Trapped in Silica and Silica-Titania Thin Films by the Sol-Gel Method Photophysical, Film and Cage Properties," JOURNAL OF NON-CRYSTALLINE SOLIDS 74, (1985), 395-406						
/T.T./	Barbe et al., "Sol-Gel Microspheres and Nanospheres for Controlled Release Applications," Controlled Release Society 29 th Annual Meeting Proceedings, #293, 545-546						
/T.T./	Butler et al., "An emulsion method for producing fine, low density, high surface area silica powder from alkoxides," JOURNAL OF MATERIALS SCIENCE 31, (1996), 1675-1680						
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/T.T./	Hou et al., "Improvement of photofatigue resistance of spirooxazine entrapped in organic-inorganic composite synthesized via the sol-gel process," SPIE, Vol. 2288 Sol-Gel Optics III, (1994), 328-339						
/T.T./	Nakatsuka, "Surface Modification of Inorganic Pigments with Organic UV Absorbers," COLLOIDS AND SURFACES 34, (1988/89), 323-324						
/T.T./	Tatapudy et al., "Benzoyl Peroxide Microcapsules I. Preparation of Core Material," INDIAN DRUGS 32(6), (1995), 239-248						
EXAMINER /Thao Tran/ (04/02/2010)				DATE CONSIDERED 04/02/2010			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

ATTY. DOCKET NO. U.S. PATENT 1268-254 APPLICATION NO. INFORMATION DISCLOSURE 10/566,369 CITATION IN AN APPLICANT APPLICATION Oleg NAIGERTSIK et al. FILING DATE **GROUP** (PTO/SB/O8A) January 30, 2006 U.S. PATENT DOCUMENTS FILING **EXAMINER'S** PATENT NO. DATE NAME CLASS **SUBCLASS** INITIALS DATE FOREIGN PATENT DOCUMENTS **EXAMINER'S** COUNTRY Equivalent DATE Abstract Translation PATENT NO. **INITIALS** 2/2006 GB 2416524 /T.T./2/2000 wo 00/09652 /T.T./ wo \mathbf{X} 5/2000 0025761 /T.T./11/2000 wo 00/71084 /T.T./ **WO** 12/2000 00/72806 /T.T./wo /T.T./11/2001 01/80823 ŴΟ /T.T./03/034979 5/2003 WO /T.T./03/039510 5/2003 8/2003 wo 03/066209 /T.T./ wo 2004/081222 9/2004 /T.T./ 5/1997 wo 97/18267 /T.T./ 7/1998 WO /T.T./ 98/31333 wo 2004/069216 8/2004 /T.T./ 1/1990 -JP 2-2867 /T.T./ /T.T./ 2-251240 10/1990 JP /T.T./9/1995 7-238983 JP /T.T./9235217 9/1997 JP X OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) **EXAMINER** DATE CONSIDERED 04/02/2010 /Thao Tran/ (04/02/2010)

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